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APPLICANT'S ART CITATION (Use several sheets if necessary)	Application			
	Applicant Takeshi NAKAMURA			
	Filing Date	Group Art Unit		

U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
/CT/	US-2001/0008067 A1	07-2001	Liebig	60	39.02	
/CT/	US-6,368,663 B1	04-2002	Nakamura et al.	427	248.1	
	US-					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
/CT/	JP 10-194856	07-1998	Japan			abstract	
/CT/	P2003-20287	01-2003	Japan			abstract	
/CT/	EP 1 277 716 A1	01-2003	Europe				
/CT/	63-012671	01-1988	Japan			abstract	
/CT/	P2000-219576	08-2000	Japan			abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/CT/	International Search Report PCT/JP2004/019518 dated 29 March 2005

Examiner	/Camie Thompson/	Date Considered	04/07/2008
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